IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of: BAILEY et al.

Application No.: 09/536,000

Filed: March 27, 2000

Title: METHOD AND APPARATUS FOR

VARYING A MAGNETIC FIELD TO CONTROL A VOLUME OF A PLASMA

Attorney Docket No.: LAINExaminer: ALEJANDRO MUSERO, L.

"n: 1763

AN 14 2002

1700 I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Box Non-Fee Amendment, Commissioner for Patents, Washington, D.C. 20231 on December 26, 2001.

Sue Funchess

AMENDMENT B TRANSMITTAL

Box Non-Fee Amendment Commissioner for Patents Washington, D.C. 20231

Sir

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	27	MINUS	27	0	x 9 =	x 18 = \$0
Independent Claims	3	MINUS	3	0	x 40 =	x 80 = \$0
Multiple Dependent Claim Present and Fee Not Previously Paid					\$135.00	\$270.00
				Total	\$	\$0

]	Applicant(s) hereby petition for a extension(s) of time to respond to the	ıe
	aforementioned Office Action.	

 \boxtimes Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required. Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. LAM1P130).

Enclosed is our Check No. in the amount of \$____ to cover the additional claim fee and/or extension of time fees.

 \square Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 50-0388 (Order No. LAM1P130).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Michael Lee

Reg. No. 31,846

P.O. Box 778

Berkeley, CA 94704-0778

PATENT

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Application No.: 09/536,000

Filed: March 27, 2000

Title: METHOD AND APPARATUS FOR VARYING A MAGNETIC FIELD TO CONTROL

A VOLUME OF A PLASMA

Attorney Docket No.: ALAM1P130/P0566

Examiner: ALEJANDRO MU

Group: 1763

8B 1/15101

CERTIFICATE OF MAILING

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on December 26, 2001.

hu Fucher

Box Non-Fee Amendment Commissioner for Patents Washington, D.C. 20231

AMENDMENT (B) AND RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action dated October 3, 2001, please amend the aboveidentified patent application as follows:

IN THE CLAIMS

Please amend claims 1, 4, 5, 9, 15, and 28 as follows:

1. (Once Amended) A plasma processing apparatus for processing a substrate, comprising:

a process chamber, defined at least in part by a top end and a bottom end and a wall extending between the top end and the bottom end, within which a plasma is ignited and sustained for said processing:

a magnetic array having a plurality of magnetic elements that are disposed around the periphery of said process chamber <u>around the outside of said wall</u>, said plurality of magnetic elements being configured to produce a magnetic field establishing a plurality of cusp patterns on said wall, <u>and wherein each of the plurality of magnetic elements spans</u>
substantially from the top end to the bottom end of the process chamber; and